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| 10/019,407 | 03/25/2002 | 438 | 2813 | 520.41003 X00 | | |
| RULE | | | | | | |
| APPLICANTS Yoshinobu Kimura, Tokyo, JAPAN; Takahiro Kamo, Mobara, JAPAN; Yoshiyuki Kaneko, Hachioji, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP00/04141 06/23/2000 ** FOREIGN APPLICATIONS ***** JAPAN 11/181559 06/28/1999 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** | | | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /LAURA MARY Acknowledged MENZ/ Examiner's Signature | | <input type="checkbox"/> Met after Allowance Initials | STATE OR COUNTRY JAPAN | SHEETS DRAWINGS 16 | TOTAL CLAIMS 20 | INDEPENDENT CLAIMS 9 |
| ADDRESS ANTONELLI, TERRY, STOUT & KRAUS, LLP 1300 NORTH SEVENTEENTH STREET SUITE 1800 ARLINGTON, VA 22209-3873 UNITED STATES | | | | | | |
| TITLE Polysilicon semiconductor thin film substrate, method for producing the same, semiconductor device, and electronic device | | | | | | |
| FILING FEE RECEIVED 1524 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |